



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/902,277
Filing Date July 9, 2001
Inventor..... Gurtej S. Sandhu et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2813
Examiner Schillinger, Laura M.
Attorney's Docket No. MI22-1780
Title: Method of Forming a Thin Film Transistor

RESPONSE TO OCTOBER 21, 2003 FINAL ACTION ACCOMPANYING RCE FILING

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Introductory Comments

In reply to the Final Office Action of October 21, 2003, applicant amends and
remarks as follows.

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